

The Photoelectric Properties of Gallium Nitride Materials and Applications in Semiconductor Lasers

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Abstract. Gallium nitride (GaN) wide bandgap devices generally have a low dielectric constant, high electron mobility, and a large bandgap. GaN is a common III-V material that has been widely used in the fabrication of electronic and optical devices such as light-emitting diodes (LEDs), lasers, and HEMTs. GaN photodetectors (PDs) are also widely used in the ultraviolet region for environmental monitoring, ultraviolet (UV) curing, etc. This article emphasizes the optoelectronic properties and semiconductor applications of GaN. GaN optoelectronic properties can be divided into three categories. The first one is band structure, which includes direct bandgap and wide bandgap (about 3.4 eV); the second one is optical properties, such as high luminous efficiency (for short wavelength emission) and absorption coefficient; the third one is electrical properties, mainly involving high breakdown field and high electron mobility (for high power devices). In addition, we discuss the application of GaN in semiconductor lasers by three different approaches. The first category is GaN-based laser structures; the second category is the application of GaN in semiconductor lasers, including blue/ultraviolet lasers and high-power lasers. Finally, we discuss challenges and advantages. Short wavelength, high efficiency, and good stability are mentioned as advantages in this section; material defects, cost, and thermal management are mentioned as disadvantages.

Keywords: GaN Material, Large Bandgap, UV Photodetector, Light-Emitting Diodes, Semiconductor Laser

1. Introduction

GaN is a very important semiconductor material from Group III-V compounds. It usually appears in two types of crystal structures: wurtzite and zincblende, but the wurtzite one is more common. GaN is a typical example of a semiconductor with a wide bandgap. At room temperature, its bandgap is 3.4 eV, which is much wider than other common semiconductors like silicon (1.1 eV) and gallium arsenide (1.42 eV) [1,2]. Because of its wide bandgap, GaN has strong properties, like being able to handle high voltages (3 MV/cm), having good thermal conductivity, and letting electrons move in it quickly. GaN's maximum hole energy and minimum electron energy are both at one spot (called the Γ point) of the Brillouin zone, which makes it a direct bandgap semiconductor. This key feature lets electron and hole pairs come together and make light easily, so GaN is great for making things like blue and UV LEDs and laser diodes. Furthermore, GaN can be mixed with aluminum nitride and

indium nitride to make ternary alloys (AlGaIn and InGaIn), which allows their bandgap to change from 1.9 eV to 6.2 eV without any breaks. This gives designers a lot of freedom to make and improve their products. People are now very interested in using GaN in strong solid-state radio frequency (RF) uses. This technology might be very helpful for things like RF switches, high-power amplifiers (HPAs), and low-noise amplifiers (LNAs) [3]. This is mainly because GaN's material properties are better than those of other semiconductors, like gallium arsenide (GaAs). Compared to GaAs, GaN has greater resistance to radiation and conducts heat better. GaN can also work at much higher temperatures, meaning its operation powers can be increased.

GaN is a leader among new-generation semiconductor materials and has changed optoelectronic devices. It has a direct bandgap of 3.4 eV that can be used for short-wavelength lighting. The structure design of InGaIn/GaN multiple quantum wells can tune the emission wavelength to achieve efficient short-wavelength light emitters from ultraviolet (200 nm) to green light (520 nm). Blue single-chip LEDs based on GaN have modern quantum efficiencies above 80%, and this has greatly advanced the solid-state lighting revolution. The AlGaIn material system in ultraviolet optoelectronic devices enables emission in the deep ultraviolet range (200 nm-365 nm). It has a unique and innovative edge that makes it difficult to replace in unique applications like UV curing and sterilization. GaN has good performance at high frequencies, and detectors that can reach GHz reaction times have been developed, making it highly promising in optical communication applications. Due to GaN's wide band gap, the devices can be used in harsh environments such as high temperatures and strong radiation. Applications are also audio the military and aerospace. III-nitride semiconductors that can be used to create LEDs and laser diodes (LDs) have optical characteristics frequently used for solid-state lighting. A broad spectrum of direct bandgap energies can be covered by alloys of GaN (3.4 eV) and InN (0.7 eV), which are frequently used [4].

GaN is a great material for a semiconductor laser due to its unique optoelectronic properties. From the optoelectronic properties aspect, GaN has a direct bandgap of 3.4 eV. This indicates that the lowest point of the conduction band and the highest point in the valence band coincide at the Γ point in the Brillouin zone. The emission wavelength can be tuned from the near-ultraviolet (365 nm) to green light (530 nm) by varying the alloy composition of InGaIn ternary alloys. GaN also has a high optical gain coefficient (10^3 cm^{-1}) as well as a high refractive index ($n \sim 2.4$).

Three key advantages of GaN-based materials can be used in semi-lasers. Blue laser diodes: Commercial InGaIn/GaN multiple quantum well (MQW) blue laser diodes are characterized by threshold current densities of less than 2 kA/cm^2 and power conversion efficiencies of more than 30% UV (450 nm). Thermal stability: Strong atomic bonding and high thermal conductivity (1.3 W/cmK) enable stable laser operation at elevated temperatures, greatly increasing device lifetime. Ultraviolet (450 nm) lasers: Bandgap engineering of AlGaIn has enabled the realization of ultraviolet (280–365 nm) semiconductor lasers, which are important for UV curing and biochemical sensing.

The photoelectric performance of GaN and GaN's application in semi-industry is the main field this article analyzes. Three aspects can be used to describe the photoelectric properties of gallium nitride. The first one is the band structure, which includes a large band gap and direct band gap characteristics. The second one is optical properties that include high luminescence efficiency and high absorption coefficient. The last one is electrical properties. This part includes high electron mobility and a strong breakdown field. Three ways can be used to address GaN applications in a semiconductor laser. The first one will be a GaN-Based Laser Structure. The second one will be Application Fields that include Blue/ultraviolet and high-power lasers. The last one is challenges and advantages. It includes advantages such as high efficiency, good stability, and short wavelength, and disadvantages such as cost, material defects, and thermal management.

2. Optoelectronic properties of GaN materials

2.1. Electronic band structure

GaN has a direct bandgap that is much wider than traditional semiconductors (Si, 1.1 eV; GaAs, 1.42 eV). Due to its broad bandgap, GaN maintains strong electric fields (3 MV/cm) and high temperatures ($>300\text{ }^{\circ}\text{C}$), making it an excellent choice for high-frequency, high-power electronics and short-wavelength optoelectronics. From the perspective of band structure, the conduction band is primarily based on the 4s orbital of the Ga atom, which is hybridized with the 2p orbital of the N atom and exhibits a steep dispersion relationship around the Γ point (the Brillouin zone center). The electron effective mass is rather low, resulting in a high. The effective mass of GaN electrons is very small, resulting in outstanding electron mobility (approximately $1000\text{ cm}^2/\text{V}\cdot\text{s}$). GaN is primarily the 2p orbital of the N atom in the valence band and usually splits into heavy-hole, light-hole, and spin-orbit bands with large energy (10 meV and 17 meV, respectively). Hole mobility ($30\text{ cm}^2/\text{V}\cdot\text{s}$) is severely hampered by its rather large effective hole mass, which ultimately restricts GaN's capacity to increase the effectiveness of p-type doping [5].

In addition, the wurtzite crystal structure of GaN exhibits robust spontaneous and piezoelectric polarization effects. At the interface of GaN, when a heterojunction is constructed with another material, AlGaN, a large polarization field will be induced. The field is generally larger than the breakdown field of GaN in Figure 1 and exhibits ultra-wide bandgap energy [6]. This effectively eliminates the need for additional doping and forms a highly concentrated two-dimensional electron plasma with a sheet density of up to 10^{13} cm^{-2} . The bandgap of GaN has a negative temperature coefficient (0.4 meV/K). Namely, it slightly narrows with increasing temperature. However, the wide bandgap can always guarantee excellent thermal stability in GaN.

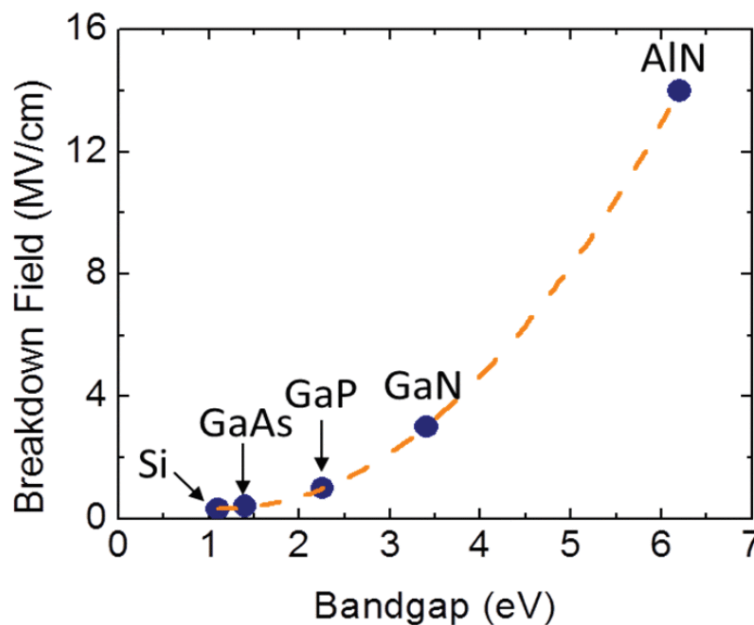


Figure 1. Breakdown field of five common semiconductors as a function of energy band gap [6]

These exceptional band structure characteristics make GaN a superior material for applications such as blue/ultraviolet LEDs, laser diodes, 5G RF devices, and high-efficiency power electronics, solidifying its role as a cornerstone of next-generation semiconductor technology.

2.2. Optical properties

As one of the third-generation semiconductor materials, GaN exhibits unparalleled optical properties, making it the material of choice for most optoelectronic applications. In terms of optical absorption characteristics, GaN exhibits extremely high absorption coefficients of $>10^5 \text{ cm}^{-1}$ in the ultraviolet and visible light bands. This property is fundamentally attributed to the direct bandgap material characteristic of GaN. It is easy for electrons to transition between the valence band and conduction band under the action of photons without momentum compensation. This highly sensitive absorption characteristic makes GaN the guillotine material for ultraviolet photodetectors [7] with ultra-high sensitivity far exceeding traditional silicon devices [8].

In terms of luminescence characteristics, the GaN material system exhibits excellent radiative recombination efficiency in blue and ultraviolet luminescence. In the luminescence wavelength range, through the design of InGaN/GaN MQW structures, precise controllable luminescence from the ultraviolet (365 nm) to green light (520 nm) wavelength can be achieved with extremely high luminescence efficiency. Modern blue GaN luminescent LEDs can achieve an ultra-high internal quantum efficiency of more than 80%, which cannot be achieved by traditional luminescent materials. More importantly, there is a unique defect tolerance in the luminescent material based on GaN, even if the dislocation density is as high as 10^8 – 10^9 cm^{-2} , excellent luminescent characteristics can still be maintained. This special characteristic is mainly due to the nanoscale composition spontaneously formed in InGaN quantum wells [9]. Fluctuations confine carriers, preventing carriers from diffusing to non-radiative defects and causing non-radiative recombination. As shown in Figure 2 [9], the fundamental structure of the MQW InGaN/GaN LED consists of a $4.33 \mu\text{m}$ Si-doped GaN substrate. On top of that, a 23 nm Si-doped $\text{Al}_{0.12}\text{Ga}_{0.88}\text{N}$ layer ($5 \times 10^{18} \text{ cm}^{-3}$) is added. In addition, the structure includes a 7 nm layer consisting of five $\text{In}_{0.2}\text{Ga}_{0.8}\text{N}$ quantum wells (QWs). The wells are sandwiched between two AlGaIn layers, where the top and bottom are p and n-type doped, respectively.

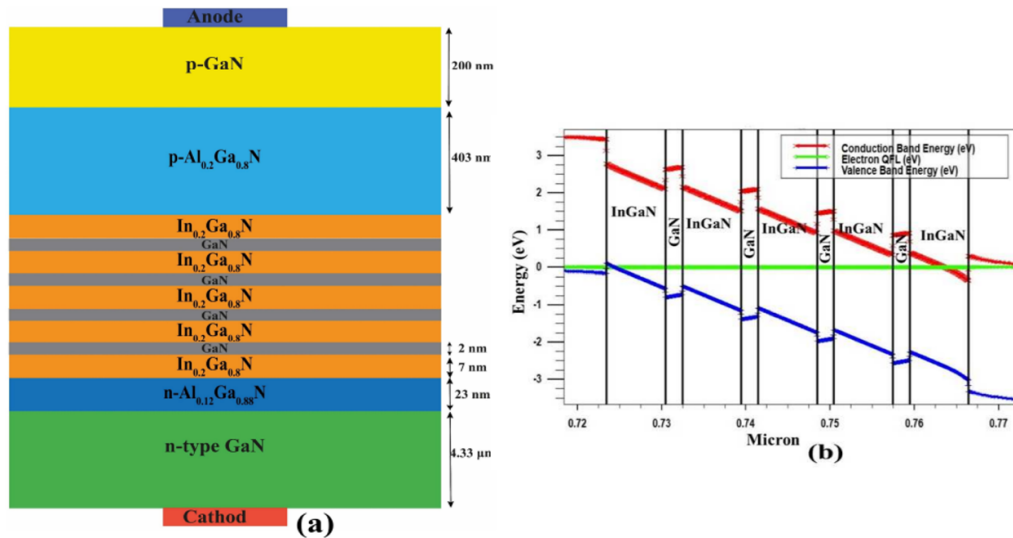


Figure 2. (a) Layout of MQWs InGaN/GaN LED (b) Energy band diagram at zero bias [9]

In addition, GaN's high refractive index (around 2.4) brings extra benefits for device design in the optoelectronics field. When incorporated with the low-refraction-index material (e.g., SiO_2), strong optical confinement structures can be constructed to greatly improve the light extraction

efficiency of LED devices. Regarding thermal stability, the bandgap temperature coefficient of GaN (-0.4 meV/K) is relatively small, rendering a stable optical performance in the high-temperature operating environment. Such excellent comprehensive nature makes GaN become the core material for the high-end optoelectronics applications represented by solid-state lighting, UV sterilization, and laser displays, and meanwhile promotes technological breakthroughs in the cutting-edge fields of deep-ultraviolet optoelectronic devices (Table 1).

Table 1. Bandgap temperature coefficient of GaN with other typical semiconductor materials

Material	Chemical Symbol	Bandgap (300K, eV)	Bandgap Temperature Coefficient (eV/K)	Temperature Range (K)	Features
Gallium Nitride [1]	GaN	~ 3.4 (direct)	-6.0×10^{-4}	100–500	Wide bandgap, high thermal stability
Silicon [1]	Si	~ 1.12 (indirect)	-2.3×10^{-4}	100–400	Traditional semiconductor
Gallium Arsenide [2]	GaAs	~ 1.42 (direct)	-4.5×10^{-4}	100–500	High-frequency, optoelectronics
Silicon Carbide (4H) [10]	4H-SiC	~ 3.26 (indirect)	-3.3×10^{-4}	100–700	High-temperature, high-power devices
Indium Phosphide [11]	InP	~ 1.34 (direct)	-3.7×10^{-4}	100–500	Optoelectronics, high-frequency
Zinc Oxide [12]	ZnO	~ 3.37 (direct)	-8.0×10^{-4}	100–500	UV optoelectronic devices
Cadmium Sulfide [13]	CdS	~ 2.42 (direct)	-4.1×10^{-4}	100–500	Photoresistors, solar cells

2.3. Electrical properties

Due to the crystal's arrangement and 3.4 eV bandgap features, GaN exhibits distinct electrical capabilities in addition to its many optoelectronics-related traits. In terms of charge carrier transport, GaN demonstrates remarkable anisotropy: the electron mobility along the c-axis direction is approximately $1000 \text{ cm}^2/\text{V}\cdot\text{s}$, while in non-polar planes it can reach $2000 \text{ cm}^2/\text{V}\cdot\text{s}$, attributable to its relatively small electron effective mass ($\sim 0.2m_0$) at the conduction band minimum[5]. Particularly noteworthy is that in AlGaN/GaN heterostructures, the strong spontaneous and piezoelectric polarization effects (with polarization field strengths reaching MV/cm magnitudes) induce the formation of a high-density two-dimensional electron gas (2DEG) at the interface, which maintains room-temperature mobility in the range of $1500\text{--}2000 \text{ cm}^2/\text{V}\cdot\text{s}$ and can still exceed $800 \text{ cm}^2/\text{V}\cdot\text{s}$ even at elevated temperatures [14]. The cross-section and arrangement of the p-GaN/AlGaN/GaN capacitor are displayed in Figure 3. On a 200 mm silicon substrate, Metal-Organic Chemical Vapor Deposition (MOCVD) is used to produce these heterostructures. An epi stack comprising a 16 or 12.5 nm $\text{Al}_{0.25}\text{Ga}_{0.75}\text{N}$ barrier layer, a GaN channel, a GaN buffer layer, and an AlN nucleation layer is developed on top of a 70 nm Mg-doped p-type GaN. To generate the final p-type GaN layer, two distinct Mg fluxes are employed

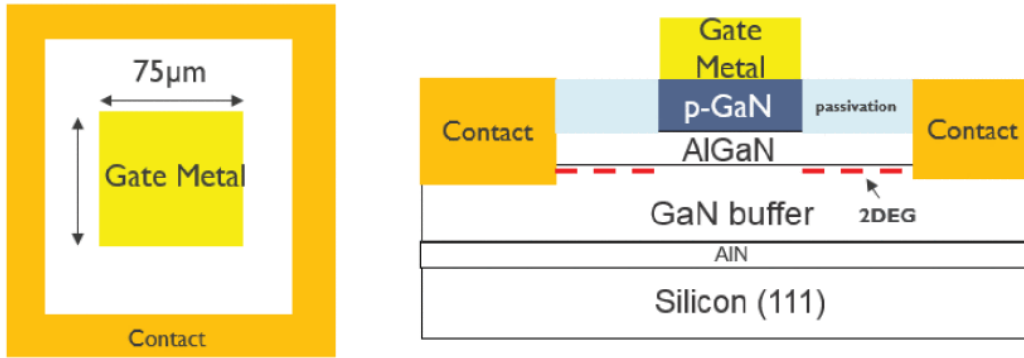


Figure 3. Layout and schematic cross-section of the measured capacitor [14]

Due to its wide bandgap nature, but also significantly due to the large energy band offsets (conduction band offset ~ 2.1 eV), GaN shows an extremely high critical breakdown field strength of 3.3 MV/cm. Compared to the Field Plate (FP) AlGaIn/GaN HEMT architecture, shown in Figure 4, the electric field distribution along the channel length is higher. In FP architecture, the electric field is spread over the distance between the gate and the drain, which reduces the peak electric field at the drain-side gate edge and hence increases the breakdown voltage [15]. This high breakdown field allows GaN devices to realize an excellent Baliga figure of merit (theoretically 3000 times higher than Si), making it possible to design high-voltage devices with low conduction losses.

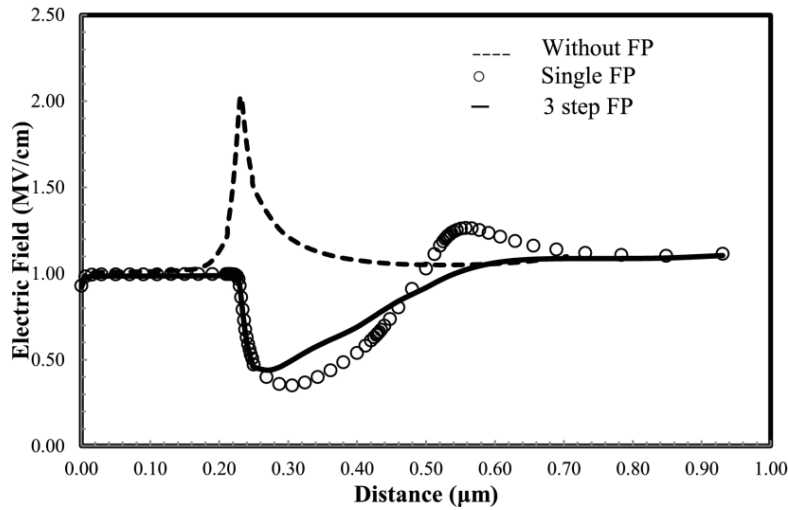


Figure 4. Distribution of the electric field along channel length for different AlGaIn/GaN HEMT architectures at $V_{DS}=200V$ and $V_{GS}=0V$ [15]

Highly asymmetric doping characteristics: n-doping (usually Si) shows great efficiency with an electron concentration up to 10^{19} cm^{-3} at room temperature, Si, with its low diffusivity, high activation efficiency, and low ionization energy, is the best choice for n-type doping of GaN [16], while p-type doping (usually Mg) is greatly limited due to the relatively deep acceptor level (~ 160 meV), and the hole concentration cannot exceed 10^{18} cm^{-3} generally. Extremely low intrinsic carrier concentration ($\sim 10^{-10} \text{ cm}^{-3}$ at room temperature) together with the relatively high thermal conductivity ($1.3 \text{ W/(cm}\cdot\text{K)}$) guarantee decent electrical stability even in high-temperature environments. These unique electrical properties make GaN an excellent material system for high-frequency and high-power electronic devices.

3. Applications of GaN in semiconductor lasers

3.1. Structure of GaN-based lasers

GaN-based laser diodes typically employ an InGaN/GaN MQW active region with a p-n junction design, featuring the following key structural components:

3.1.1. Substrate selection

Traditional GaN-based LED chips have six sides and are rectangular. The primary structure is made up of a sapphire substrate that is about 100 μm thick and a GaN epitaxial layer that is about 6 μm thick. The LED's light is produced in the MQW when an electric current is introduced into the LED chip. The light travels through the GaN/Air and Sapphire/Air interfaces and emits forth. Since GaN and sapphire substrates have refractive indices that are significantly higher than those of air ($n_{\text{GaN}} \sim 2.5, n_{\text{sapphire}} \sim 1.8, n_{\text{air}} = 1$), total internal reflection on the GaN/Air and Sapphire/Air interfaces happens with ease. The critical angles of GaN/Air and Sapphire/Air are 23.5° and 33.7° , respectively, based on Snell's law ($n_1 \times \sin \theta_c = n_{\text{air}} \times \sin \theta_{\text{air}}$) [17].

3.1.2. N-type region

The two components of the N-type area are the silicon-doped In-GaN layer ($5 \times 10^{18} \text{ cm}^{-3}$) and the n-AlGaIn electron confinement layer, which is 2–5 μm thick. This area is frequently utilized for optical confinement and electron injection. Figure 5 (a) illustrates that the light output power increases by 146% and 69%, respectively, when the p-AlGaIn EBL is removed and the n-AlGaIn/n-GaN SL EBL or n-AlGaIn is situated between the active region and the n-GaN layer [18]. The three devices' I-V curves in Figure 5(b) demonstrate that the LEDs with N-AlGaIn/N-GaN SL EBL and N-AlGaIn EBL have some improvement in terms of carrier transport, as seen by the drop in on-state voltage and series resistance.

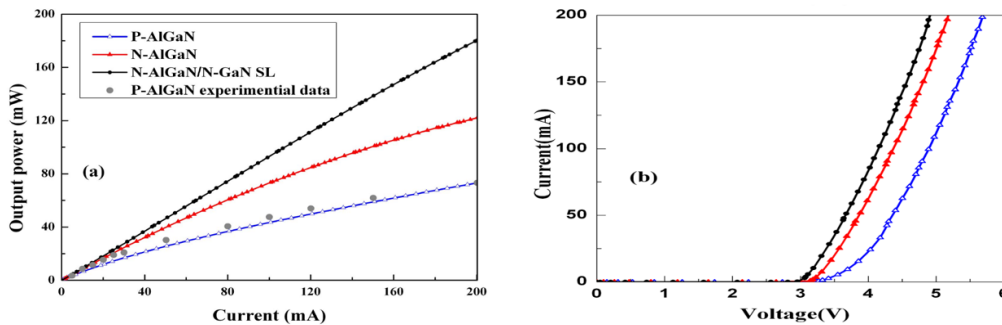


Figure 5. (a) Light output power, (b) IV curves [18]

3.1.3. P-type region

Polarization engineering or superlattice structures are typically employed to address the hole injection issue. Additional solutions to this issue include the p-AlGaIn hole confinement layer and the p-GaN contact layer (Mg-doped, $1 \times 10^{19} \text{ cm}^{-3}$). A transmission electron microscope (TEM) picture in cross-section is displayed in Figure 6(a). Approximately $2 \times 10^{19} \text{ cm}^{-3}$ and $1 \times 10^{19} \text{ cm}^{-3}$ of magnesium doping are present in the p-GaN and p-AlGaIn areas, respectively, based on the

secondary ion mass spectrometry (SIMS) analysis shown in Figure 6(b) [19]. Diffusion during epitaxial growth has not been shown to significantly alter the distributions of Mg and Al doping.

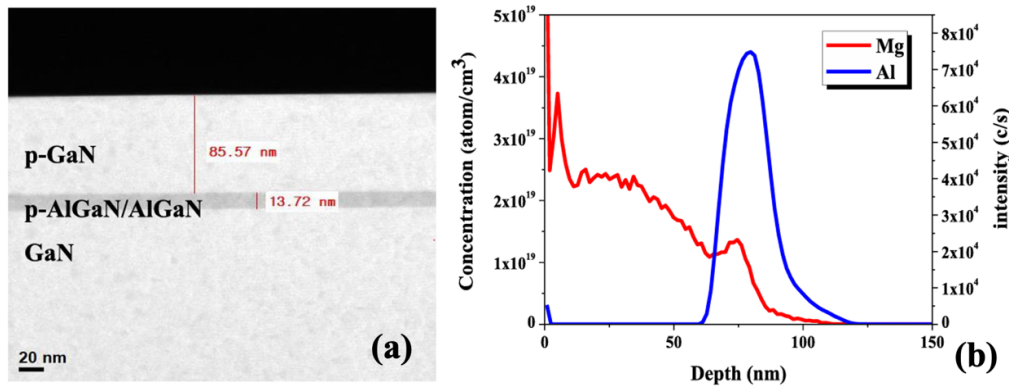


Figure 6. (a) Cross-sectional TEM image of the epitaxial structure (b)Mg and Al doping concentration distributions of p-GaN/p-AlGaN/AlGaN/GaN epitaxial structure analyzed by SIMS measurements [19]

3.1.4. Active region

The core structure features eight periods of InGa_N/Ga_N MQWs [20], where each period is designed with a 3-nm InGa_N QW and a 13-nm Ga_N barrier, ensuring effective carrier confinement and optical emission. The growth temperatures were 705°C and 850 °C for QWs and QBs, respectively [21]. Emission wavelength (450-530 nm) is controlled by indium content (15-20%). Radiative recombination efficiency is maximized using strain engineering.

3.1.5. Optical cavity

Dry etching was used to create the Fabry-Pérot resonator, which has a cavity length of 300–1000 μm. Optical feedback is provided by High-Reflection/ Anti-Reflection coatings on facets. Newer designs use vertical-cavity surface-emitting lasers (VCSELs) or distributed feedback combinations. GaN-based resonant cavity light-emitting diodes (RCLEDs) and VCSELs provide superior directionality, shorter linewidths, more stable peak wavelengths, and higher output coupling efficiency [21] when compared to traditional LEDs. A distributed Bragg reflector can also be used to manufacture GaN-based RCLEDs [22].

3.2. Application fields of GaN in semiconductor lasers

GaN-based semiconductor lasers have found widespread applications across multiple fields due to their outstanding performance, primarily in the following areas:

3.2.1. Blue/ultraviolet lasers

The substantial improvement in GaN crystal quality enabled researchers to control the conductivity of both p- and n-type nitride semiconductors, which made it possible to fabricate the high-brightness GaN-based p-n junction blue-LED and the high-performance violet/blue LD [23]. GaN-based semiconductor lasers have been widely used in various fields because of their remarkable performance mainly in the following three fields. The first one is Data Storage: Due to its short

wavelength, the 405 nm blue-violet laser is the main light source for the Blu-ray/HD-DVD system (the currently available technology), with a much larger storage volume (>50 GB single disc) due to its short wavelength. The second one is the laser display: It is already applied in laser TVs and movie projection systems, which are enabled by 450 nm blue lasers and phosphor conversion. The third one is Optical Communication: GaN UV laser can realize short-range atmospheric optical communication with a modulation bandwidth at the GHz level.

3.2.2. High-power lasers

Automotive Applications is one industry. GaN blue lasers (450–470 nm) enable next-generation laser headlights that offer ultra-bright (>100,000 lux), energy-efficient illumination with flawless beam control. Light Detection and Ranging (LiDAR) systems that use pulsed GaN lasers (905 nm via frequency doubling) provide autonomous vehicles with long-range, high-resolution 3D sensing, enhancing object detection in low-visibility scenarios. Despite being relatively new, LiDAR sensors are finding widespread use in automotive applications due to their ability to offer high resolution, real-time 3D colorful point clouds of surroundings in low visibility settings with a long and wide detecting range [24]. They are therefore the next development in the direction of complete driverless capabilities [25]. Another industry is communication technology. Monolithically integrated PDs in InGaN/GaN LEDs are frequently used to track variations in LED intensity over time, which can significantly increase the optical power stability of LEDs. When it comes to high-speed modulation and high-brightness lighting, LDs perform noticeably better than LEDs. Using the same InGaN/GaN multi-QW active area, a waveguide PD with an edge-emitting LD was designed. An integrated PD-LD device can be built if it can be produced on a single chip. By integrating a waveguide PD (WPD) on a semi-polar GaN substrate, a skilled research team in China has now effectively produced such a device [26].

3.3. Advantages and challenges of GaN in semiconductor lasers

GaN has emerged as a key material for semiconductor lasers, particularly in the blue and UV wavelength ranges. GaN's unique properties offer several advantages but also present challenges in device fabrication and performance.

Advantages of GaN in Semiconductor Lasers: Initially, the wide bandgap (3.4 eV for GaN and 6 eV for AlGaN): GaN is the most promising material for UV, blue, green, and white high-brightness LEDs [27], which are essential for devices like optical storage, laser projectors, and Blu-ray discs. A greater voltage of breakdown than conventional III-V materials. Second, high efficiency & power output: molecular beam epitaxy's AlGaN-delta-GaN QW structure, which was constructed using a conventional AlN/sapphire template, showed a high internal quantum efficiency (85%) [28]. High-power continuous-wave (CW) and pulsed operation capabilities make it valuable for LiDAR, medical lasers, and industrial cutting [24]. Third, Thermal and Chemical Stability: GaN-based lasers reduce thermal droop and have superior thermal conductivity (130 W/m·K) compared to GaAs (50 W/m·K). They are appropriate for extreme environments and aerospace because they are resistant to radiation damage.

GaN Semiconductor Lasers also have many key challenges: Material flaws are one issue: High defect density: efficiency is decreased by heteroepitaxy-induced dislocations (10^8 – 10^{10} cm⁻²). Inadequate p-type doping: high driving voltage results from low magnesium activation efficiency. "Green gap": Because of InGaN phase separation, efficiency drastically decreases beyond 530 nm. Thermal issues are another issue. Efficiency droop: performance is deteriorated by carrier leakage at

high current. Local heating: without sophisticated cooling, temperatures in the active region can reach 150°C. Thermal stress: In high-power operation, cracking results from a mismatch in the coefficient of thermal expansion. High costs are the final problem: expensive substrates (silicon costs more than \$100 for GaN native wafers). Complex fabrication: Gold-heavy connections and dry etching are needed for mirrors. Testing overhead: to validate reliability, about 1000 hours of burn-in are required.

4. Conclusion

To sum up, as a third-generation semiconductor, GaN has a wide bandgap (3.4 eV), a high breakdown field strength, and excellent chemical stability, enabling efficient UV-to-blue/green emission. Because GaN has a direct bandgap and high internal quantum efficiency (>80%), it is particularly suitable for short-wavelength laser applications, providing efficient high-power output without the need for frequency conversion. In laser applications, GaN's high thermal conductivity (130 W/m·K) facilitates heat dissipation. However, there remain multiple challenges, such as efficiency droop and difficulty in p-type doping. State-of-the-art heat management and optical performance improvement methods, such as microfluidic cooling and nano-patterned surfaces, enable performance optimization. GaN lasers have already been widely commercialized in optical storage (Blu-ray), laser displays, and LiDAR. They also have great potential in visible light communication and medical UV sources.

The future of GaN technology will be centered around three development directions. Efficiency improvement: optimized epitaxial growth techniques, especially p-GaN doping and dislocation reduction, to reduce efficiency droop and improve light output; cost reduction: mass production and cost reduction using large-scale GaN-on-Si and GaN-on-diamond technologies; application expansion: advanced Micro-LEDs for augmented reality/virtual reality displays, quantum dot lasers for tunable visible-light emission for communications and sensing applications.

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